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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Akira Hashimoto

: Art Unit:

Serial No.:

To Be Assigned

: Examiner:

Filed:

Herewith

.

FOR:

METHOD FOR MANUFACTURING CERAMIC

SUBSTRATE

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents Washington, D.C. 20231

SIR:

Prior to examination, please amend the above application as follows:

IN THE SPECIFICATION:

After the title and before the first paragraph, please insert the following paragraph:

THIS APPLICATION IS A U.S. NATIONAL PHASE APPLICATION OF PCT INTERNATIONAL APPLICATION PCT/JP01/04818.

IN THE DRAWINGS:

Please delete pages "10/11" and "11/11" of the drawings, also labeled as "Reference numerals in the drawings" in its entirety.

IN THE CLAIMS:

Please replace claims 3, 6, 9, 10, 13, 14, and 17-19 with the following amended claims:

3. (Amended) The method of claim 1, further comprising the steps of:

forming a via-conductor through forming a through-hole in the un-sintered green sheet; and

14.

connecting the conductive pattern to the via conductor.

- (Amended) The method of claim 4, further comprising the steps of: 6. forming a via-conductor through forming a through-hole in the un-sintered green sheet; and connecting the conductive pattern to the via-conductor.
- 9. (Amended) The method of claim 7, further comprising the steps of: forming a via-conductor through forming a through-hole in the un-sintered green sheet; and connecting the conductive patterns to the via-conductor.
 - 10. (Amended) The method of claim 7, further comprising the steps of: forming a via-conductor through forming a through-hole in the sintered substrate; and connecting the conductive pattern to the via-conductor.
- 13. (Amended) The method of claim 11, further comprising the step of: forming a via-conductor through forming a through-hole in the un-sintered green sheet; and connecting the conductive patterns to the via-hole conductor.
- (Amended) The method of claim 11, further comprising the steps of: forming a via-conductor through forming a through-hole in the sintered ceramic substrate; and

connecting the conductive pattern to the via-conductor.

17. (Amended) The method of claim 15, wherein the first intaglio and the second intaglio are identical to each other.

18. (Amended) The method of claim 15, further comprising the steps of:

forming a first via-conductor through forming a through-hole in the un-sintered green sheet; and

connecting at least one of the first and second conductive patterns to the first viaconductor.

19. (Amended) The method of claim 15, further comprising the steps of:

forming a second via-conductor through forming a through-hole in the sintered ceramic substrate; and

connecting at least one of said first and second conductive patterns to the second viaconductor.

Sespectfully submitted

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LEA/fp

Enclosure: Version With Markings Showing Changes Made

Dated: February 7, 2002

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The Assistant Commissioner for Patents is hereby authorized to charge payment to Deposit Account No. **18-0350** of any fees associated with this communication.

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I hereby certify that this paper and fee are being deposited, under 37 C.F.R. § 1.10 and with sufficient postage, using the "Express Mail Post Office to Addressee" service of the United States Postal Service on the date indicated above and that the deposit is addressed to the Assistant Commissioner for Patents, Washington, p.C. 20231.

Kathleen Libby

VERSION WITH MARKINGS SHOWING CHANGES MADE

Please replace claims 3, 6, 9, 10, 13, 14, and 17-19 with the following amended claims:

- 3. (Amended) The method of claim 1-or-2, further comprising the steps of: forming a via-conductor through forming a through-hole in the un-sintered green sheet; and
 - connecting the conductive pattern to the via conductor.
- 6. (Amended) The method of claim 4-or 5, further comprising the steps of:

 forming a via-conductor through forming a through-hole in the un-sintered green sheet;
 and

 connecting the conductive pattern to the via-conductor.
- 9. (Amended) The method of claim 7-or-8, further comprising the steps of:

 forming a via-conductor through forming a through-hole in the un-sintered green sheet;
 and

 connecting the conductive patterns to the via-conductor.
- 10. (Amended) The method of any one of claims claim 7-to-9, further comprising the steps of:
 - forming a via-conductor through forming a through-hole in the sintered substrate; and connecting the conductive pattern to the via-conductor.
- 13. (Amended) The method of claim 11-or-12, further comprising the step of:

 forming a via-conductor through forming a through-hole in the un-sintered green sheet;
 and

connecting the conductive patterns to the via-hole conductor.

14. (Amended) The method of any one of claim claims 11-to 13, further comprising the steps of:

forming a via-conductor through forming a through-hole in the sintered ceramic substrate; and

connecting the conductive pattern to the via-conductor.

- 17. (Amended) The method of claim 15-or-16, wherein the first intaglio and the second intaglio are identical to each other.
- 18. (Amended) The method of any one of claims claim 15 to 17, further comprising the steps of:

forming a first via-conductor through forming a through-hole in the un-sintered green sheet; and

connecting at least one of the first and second conductive patterns to the first viaconductor.

19. (Amended) The method of any one of claims claim 15-to 18, further comprising the steps of:

forming a second via-conductor through forming a through-hole in the sintered ceramic substrate; and

connecting at least one of said first and second conductive patterns to the second viaconductor.